

## §25. Development of $V_3Ga$ Superconducting Wires by Using V-Ga and Ti-Ga Compound as High Ga Source Material

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$V_3Ga$  compound superconducting material is attractive in the several V-based compounds as high magnetic field and low activation superconducting wire materials.  $V_3Ga$  compound has high upper critical magnetic fields ( $H_{c2}$ ) above 20 T as well as  $Nb_3Sn$  and it is better mechanical property than  $Nb_3Sn$  compound. Furthermore,  $V_3Ga$  compound was historically origin material to succeed development of “Bronzed process” on commercial  $Nb_3Sn$  wire.

In the previous study, the wire process of  $V_3Ga$  compound was mainly investigated “Bronzed process” between Cu-Ga solid solution within 20 at%Ga composition and V filament. One of authors, Hishinuma et al., investigated that new route  $V_3Ga$  wire process synthesized by Powder In-Tube (PIT) process using high Ga content Cu-Ga compound powder above 20at%Ga composition. We also investigated that another PIT process using V-Ga binary system compound as the high Ga content compound.

A lot of the high Ga content phases were existed in the V-Ga binary system, and they were  $V_6Ga_5$ ,  $V_6Ga_7$ ,  $V_2Ga_5$  and  $V_8Ga_{41}$ , respectively. In the view points of the wire drawing process,  $V_2Ga_5$  phase was desirable material in these high Ga content phases due to the high melting point above  $1000^\circ C$ .  $V_2Ga_5$  compound was made by arc-melting method, and arc-melting button was carried out solution heat treatment at  $800^\circ C$ . From the EDX and EPMA analyses, base matrix and small amounts of the precipitate were confirmed to the  $V_2Ga_5$  and  $V_8Ga_{41}$  compounds in the arc-melting button. The arc-melting button after the solution heat treatment was crushed easily

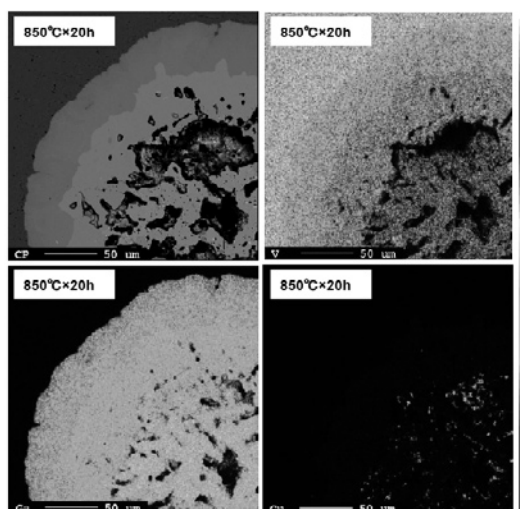


Fig.1 The element distribution into the diffusion layer on the  $V_2Ga_5+10wt\%Cu$  addition /V precursor.

by hand-milling.  $V_2Ga_5$  compound was packed into metal V tube and the composite was carried our wire deformation, and then the diffusion pairs between  $V_2Ga_5$  compound and metal V were prepared. And the other hand, Cu addition diffusion pair which was mixture of 10wt% Cu powder and  $V_2Ga_5$  compound was also prepared in order to study about Cu addition effect.

The comparison of the element distribution in diffusion layer on the  $V_2Ga_5+10wt\%Cu$  addition /V precursor by EPMA analysis are shown in Fig.1. The thick diffusion layer was formed around the interface between  $V_2Ga_5$  powder core and metal V matrix, and the volume fraction of  $V_3Ga$  layer was increased remarkably by the 10wt% Cu addition. Additional Cu did not diffuse into the  $V_3Ga$  phase, and it was confirmed clearly that additional Cu promoted to form  $V_3Ga$  phase as well as conventional “Bronzed process” of  $Nb_3Sn$  and  $V_3Ga$  wire.

The Ti-Ga compounds, which are  $TiGa_2$  and  $TiGa_3$ , are the other high Ga content compound. These compounds are made by arc-melting as well as  $V_2Ga_5$  compound. Because  $TiGa_3$  and  $TiGa_2$  compounds are high melting point materials above  $1000^\circ C$ . Fig. 2 shows back scattering electron (BSE) image of the arc-melted  $TiGa_3$  button (as cast). As cast button, dendritic  $TiGa_2$  compound was mainly formed into liquid metal Ga. The solid solution heat treatment as  $800^\circ C \times 10h$  was carried out the as cast button. After the heat treatment,  $TiGa_2$  compound was reacted to liquid metal Ga, and  $TiGa_2$  compound was transformed to the  $TiGa_3$  compound. This compound was easy to crush to fine powder.  $TiGa_3$  fine powder was packed into V tube, and  $TiGa_3/V$  composite precursor was drawn to mono-cored wire having 1.04mm diameter.

In the future, the superconducting property of the  $TiGa_3/V$  mono-cored wire will be measured. The comparisons between  $V_2Ga_5$  and  $TiGa_3$  on the superconducting properties and microstructure will also be investigated.

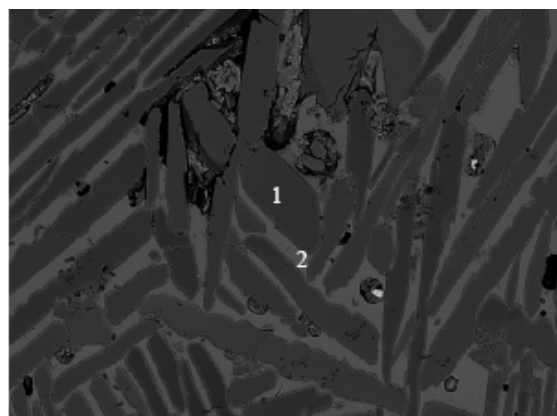


Fig.2 Typical back scattering electron (BSE) image of the arc-melted  $TiGa_3$  button. 1:  $TiGa_2$ , 2: non-reacted Ga (liquid)